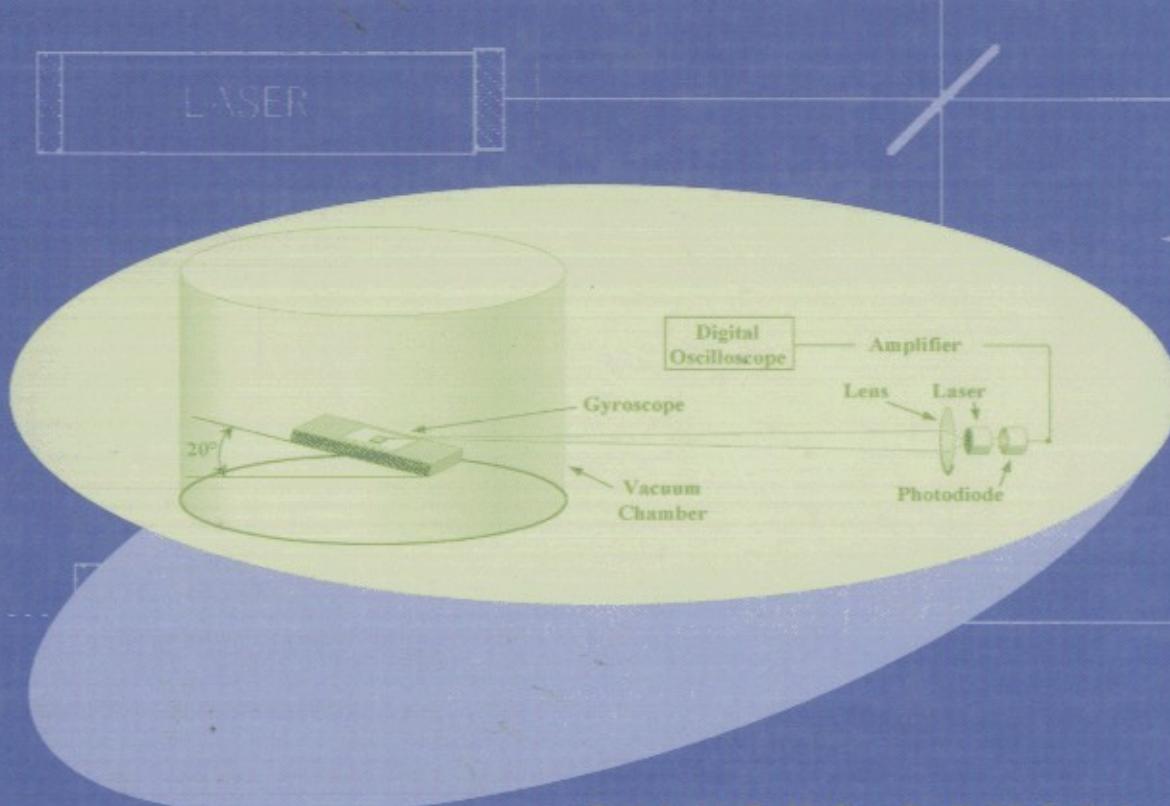


# ELECTRO-OPTICAL INSTRUMENTATION

SENSING AND MEASURING WITH LASERS



SILVANO DONATI

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